



Corres. and Mail  
**BOX AE**

MAIL STOP AF  
RESPONSE UNDER 37 C.F.R. § 1.116  
**EXPEDITED PROCEDURE**  
**EXAMINING GROUP 2100**

*AFB*  
*W*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. Granik et al. Attorney Docket No.: MEGC117332  
Application No.: 09/898,431 Group Art Unit: 2123 / Confirmation No. 1914  
Filed: July 2, 2001 Examiner: T.H. Stevens  
Title: METHOD OF COMPENSATING FOR ETCH EFFECTS IN  
PHOTOLITHOGRAPHIC PROCESSING

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116/

PETITION FOR EXTENSION OF TIME

Seattle, Washington 98101

December 2, 2005

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

Please amend the above-identified application as follows.

12/06/2005 DTESSEN1 00000062 09898431

01 FC:1251

120.00 0P

LAW OFFICES OF  
CHRISTENSEN O'CONNOR JOHNSON KINDNESS<sup>PLC</sup>  
1420 Fifth Avenue  
Suite 2800  
Seattle, Washington 98101  
206.682.8100